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Bib Data Sheet

CONFIRMATION NO. 7998

SERIAL NUMBER 10/615,051	FILING DATE 07/07/2003  RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. MI22-2308
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## APPLICANTS

Brian A. Vaartstra, Nampa, ID;

\*\* CONTINUING DATA \*\*\*\*\*

BU, NONE

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

BU, NONE

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 10/02/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <u>Bd</u> Initials _____	ID	3	58	3

## ADDRESS

021567  
WELLS ST. JOHN P.S.  
601 W. FIRST AVENUE, SUITE 1300  
SPOKANE, WA  
99201

## TITLE

Methods of forming a phosphorus doped silicon-dioxide-comprising layer, and methods of forming trench isolation in the fabrication of integrated circuitry

FILING FEE  RECEIVED 1434	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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